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(Form PTO/SB/08)

Application Number	To Be Assigned
Filing Date:	Herein
First Named Inventor	Ferdi SCHÜTH et al
Art Unit	To Be Assigned
Examiner Name:	To Be Assigned
Attorney Docket Number:	100716-62 KGB

Sheet 1

of 1

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. ¹	Document Number Number-Kind Code ²	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/D.B./	A	US - 5,248,649 A	09-28-1993	Mosley	
/D.B./	B	US - 4,958,098 A	09-28-1999	Heung	
/D.B./	C	US - 5,411,928 A	05-02-1995	Enz et al	
/D.B./	D	US - 6,528,441 B1	03-04-2003	Heung et al	
/D.B./	E	US - 4,798,718 A	01-17-1989	Bogdanovic	
	F	US -			

FOREIGN PATENT DOCUMENTS

Examiner's Initials*	Cite No.	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	G	DE 101 63 697 A	07-03-2003	Studiengesellschaft Kohle mbH		
	H					
	I					

NON PATENT LITERATURE DOCUMENTS

Examiner's Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
	J	HEILING, I. K. et al; "Silica embedded metal hydrides"; <i>Journal of Alloys and Compounds</i> , Elsevier Sequoia, Lausanne, CH; Vol. 293-295, December 20, 1999; pages 446-451	
	K	GUAY, P. et al; "On the control of carbon nanostructures for hydrogen storage applications"; <i>Carbon</i> XX, XX, Vol. 42, No. 11; (2004); pages 2187-2193.	
	L	ROSI, N. L. et al; "Hydrogen storage in microporous metal organic frameworks"; <i>Science</i> , Vol. 300; May 16, 2003; pages 1127-1129.	
	M		

EXAMINER SIGNATURE: /Dung Bui/

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